



a. General

Vendor / Supplier	TEL
Model	TACTRAS NCCP
Process	ETC_GatePatterning
Vintage (Year of Manufacture)	March 2010
Asset Description	
Tool Status	Cold Idle
Software Version	V5.80c
CIM	E84, SECS/GEM, GEM300, Interface A

b. Hardware Configuration

Main System	TACTRUS NCCP	1	
SMIF System	Load ports	5	
	Loader Module	1	
	Loadlock module	1	
Handler System	Vacuum Transfer Module	1	
Options			
Others (Pls specify if any)			

c. Hardware Configuration (Subfab / Auxilliary Units)

AC power Rack	1	OK	
RF generators	4	OK	
Pump Rack	1	OK	
Pumps	4	OK	
Chillers	4	OK	

d. Missing/Faulty Parts / Accesories List

(If NO missing/faulty parts/accessories please indicate NA)

None	-	
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Tool Status	Cold Idle
Chamber Components	
Tool Description	TEL-TACTRAS-2ch NCCP
Supplier Name	Tokyo Electron Limited
Model Number	Tactras
Tool's Recipe Capability	Multiple Recipe
Does the tool have a SECS/GEM interface?	Yes
How many ports does this tool have?	5
Protocol Zones Allowed	FEOL
Chamber ID's or Station ID's	Chamber or Station Description
PM1	Yes
PM2	Yes
PM5	Yes
PM6	Yes